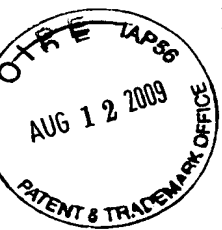


IFW

U.S. Serial No.: 10/569,838

Docket No.: F06-436-US

FUJIT.081



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Mineo HIRAMATSU, et al.

Serial No.: 10/569,838

Group Art Unit: 1792

Filed: December 1, 2006

Examiner: LOUIE, MANDY C

For: METHOD FOR PRODUCING CARBON NANOWALLS, CARBON
NANOWALLS, AND APPARATUS FOR PRODUCING CARBON
NANOWALLS

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

**RESPONSE TO FIRST OFFICE ACTION AND
RESTRICTION REQUIREMENT**

Sir:

In response to the Office Action dated July 30, 2009, please consider the
following:

INTRODUCTORY COMMENTS

Remarks begin on page 2 of this paper.